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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Docket No.:

2771-546-CIP1

Applicants:

DIMEO JR., Frank, et al.

Conf. No.:

8335

Application No.:

10/784,606

Art Unit:

2856

Date Filed:

October 17, 2002

Examiner:

Jacques M. Saint

Surin

Title:

**NICKEL-COATED FREE-**

STANDING SILICON

CARBIDE STRUCTURE FOR SENSING FLUORO OR

HALOGEN SPECIES IN SEMICONDUCTOR PROCESSING SYSTEMS, AND PROCESSES OF

MAKING AND USING SAME

**Customer No.:** 

23448

## FACSIMILE TRANSMISSION CERTIFICATE ATTN: Examiner Jacques M. Saint Surin Fax No. (571) 273-8300

I hereby certify that this document, along with any enclosures identified herein, is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date specified below, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

14

Number of Pages (including cover)

Vincent K. Gustafso

April 11, 2007

Date

## RESPONSE TO JANUARY 12, 2007 OFFICE ACTION IN U.S. PATENT APPLICATION NO. 10/784,606

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

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Sir:

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This responds to the January 12, 2007 Office Action in the above-referenced application.

Please amend the claims of the above-identified patent application as set out in Section I (Amendments to the Claims) hereof.

Remarks concerning the amendments of the claims and the substance of the January 12, 2007 Office Action are set out in Section II (Remarks) hereof.